
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(219.005-US-C1)

In re Application of: YAMADA ET AL.)	
)	
Serial No: CONTINUATION OF 10/082,247)	Group Art Unit:
)	
U.S. Filing Date: FEBRUARY 27, 2004)	Examiner:
)	
Title: PRODUCTION MANAGING SYSTEM)	
OF SEMICONDUCTOR DEVICE)	

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

FIRST PRELIMINARY AMENDMENT

Dear Sir:

Preliminary to the examination of the above-referenced application, kindly amend the application as follows: